## **MCM-41**

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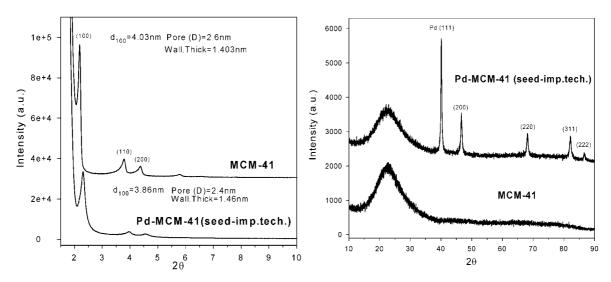
<u>,</u> ,

## Synthesis of Pd Inserted MCM-41 and Application for Hydrogenation of Carbon Dioxide to Methanol

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가 가 .[1,2]MCM-41 hexagonal array channel seed pore impregnation Pd/MCM-41 acid Pd nanowire가 narrow size distribution [2-4]가 가 Pd/MCM41 active site가 metal particle size가 Pd particle size focus가 particle size control 가 Microemulsion 가 10nm 1.8nm 가 particle size 가 supporter migration active site가 alloy가 alloy .[5] microemulsion broad particle size 2nm range particle size distribution , narrow mono-disperse ) Pd nano particle mesoporous material , zinc mold (with good supporter) ZMS(Zinc Molecular Sieve) 가 가 surfactant MCM-41: homogeneous mixture가 가 16 **CTAB** stirring Surfactant (cetyltrimethylammoniumbromide) homogeneous mixture가 vigorous stirring  $SiO_2$ Na<sub>2</sub>O dropwise addition Surfactant :  $SiO_2$ :  $Na_2O$  :  $H_2O$  = 0.25 : 1 : 0.25 : 50 . 1 가 stirring gel mixture hydrothermal treatment 100°C . Room temperature pH = 10.2가 cooling acetic acid pH control 3 hydrothermal treatment pH control MCM-41 pН

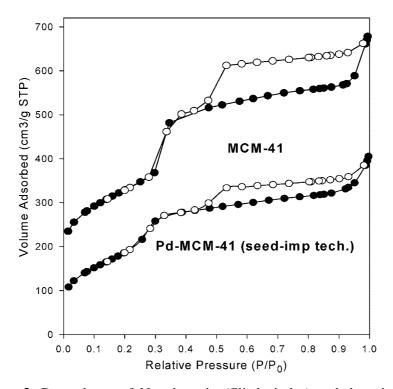
```
control
                   salt treatment
                                                     salt
                                                            NaC1
                                                                        surfactant
        가
                                         filtering, washing
                                                                              drying(R.T. for 12h
and 110°C for 6h)
                               (550 °C for 6h)
                                                       mesoporous silica가
                                                        200ml
        Pd/MCM-41 by seed-imp.: MCM-41 2g
                                                                                   MCM-41
           Pd(Palladium nitrate)
                                    seed
0.5wt%
                                                                 stirring
                  110 °C
                                                                                  350 °C
                                                                                               2
      filtering
                               12
                                             Drying
                        300 °C
                                     2
                                                          reduction
                             5wt%
                                      Pd
                                                        wet-impregnation
                         stirring
                                            evaporation, Drying
300°C
                         reduction
                                              Pd
                                                             MCM-41
        Free standing Pd nanowire:
                                                Pd/MCM-41
                                                                10wt%
                                                                           HF/EtOH solution
      2
                            stirring
                                                                    Si
                                                                                solution
                         filtering
                     TEM
                                                             (O.D. =3/8 inch)
                                                                                  glass wool
silicon wool
                     glass bead
                                                                                      200 ml / min
(WHSV = flow rate of feed gases / weight of catalyst)-weight hourly space velocity of 3H<sub>2</sub>/CO<sub>2</sub> =200
                                                                 3:1
ml/min/g
                                                                                   . PID controller
                            가
                                                           가
                                                                                        523K
                      가
                               30 atm
                                                           MFC(Brooks 5850)
                                                                                   Back Pressure
                                가
regulator(Tescom)
                                    sampling
                                                 6-port valco valve
                                                                                               GC
5890(II)
                   impregnation
                                            Pd
                                                  MCM-41
                                                                             pore
                                                                                       가
  가
      seed-impregnation technique
                                                                  Pd
                                                                         seed
washing
                  wall
                                                                       Pd
                                                                                 impregnatiom
reduction
                           Pd seed
                                        pore
                                                                          가
                              Pd
                                                            wall
                loading
                                                                                          가
                              impregnation
        Figure 1
                      X-ray diffraction pattern
                                                                               Low-angle
MCM-41
                   peak
                             MCM-41
Pd
                                  hexagonal array structure가
                 intensity가
        . Peak
                                                                      pore
                                                                                Pd
                                                     X-ray diffraction pattern
                                  High-angle
                 Pd
                                               peak
                            peak
                                                                                         MCM-41
        BET
                                                                   Pd/MCM-41
                           surface area
                                            pore volume
                  surface area7 822.7 m<sup>2</sup>/g
MCM-41
                                                          Pd/MCM-41
                                                                          669.2 \text{m}^2/\text{g}
      Pore volume
                           0.85 \text{cm}^{3}/\text{g}
                                            0.57 \, \text{cm}^3/\text{g}
```



**Figure 1**. Low angle X-ray diffraction pattern for the MCM-41 and Pd/MCM-41

**Figure 2**. High angle X-ray diffraction pattern for the MCM-41 and Pd/MCM-41





**Figure 3**. Dependence of  $N_2$  adsorption(filied circles) and desertion(open circles) isotherms for the MCM-41 and Pd/MCM-41

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TEM image figure 4 channel Pd . Pore 2.4nm metal wall 가 . Pd nanowire가

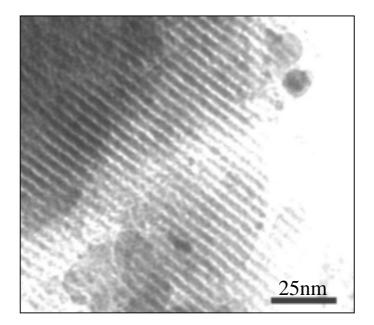


Figure 4. TEM image of palladium inserted MCM-41

material

Supporter zinc si

Pd/MCM-41 conversion . SiO<sub>2</sub>

Pd nano particle .

BK-21 .

<sup>[1]</sup> A.P.Alivisatos, Science, **271**, 933 (1996).

<sup>[2]</sup> Kyung-Bok Lee, Sang-Min Lee, and Jinwoo Cheon, Adv.Mater.,13, No. 7 (2001).

<sup>[3]</sup> Hyun June Shin, Chang Hyun Ko and Ryong Ryoo, J.Mater.Chem, 11, 260-261 (2001).

<sup>[4]</sup> Zheng Liu, Yasuhiro Sakamoto, Tetsu Ohsuna, Kenji Hiraga, Osamu Terasaki, Chang Hyun Ko, Hyun June Shin, and Ryong Ryoo, Angew. Chem. Int. Ed., 39, No.17 (2000).

<sup>[5]</sup> J.Y.Lee, POSTECH, Master thesis, (2001).

<sup>[6]</sup> Hongkyu Kang, Young-wook Jun, Jong-Il Park, Kyung-Bok Lee, and Jinwoo-Cheon, Chem.Mater.12, 3530-3532 (2000).